



Docket No. WP 21379 US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: ZIEGLER, Friedrich

Application No.: 10/620,217

Group No.: 3662

Filed: July 15, 2003

Examiner: Brian K. Andrea

For: Reflection-Photometric Analytical System

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED JUNE 8, 2004

Sir:

Responsive to the Office Action mailed June 8, 2004, Applicant respectfully requests that the Examiner enter the following amendment(s). A Petition for Extension of Time for three (3) months is submitted herewith.

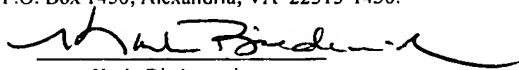
Amendment to the Claims are reflected in the listing of the claims that begin on Page 2 of this paper.

Remarks begin on Page 6 of this paper.

Conclusion begins on Page 8 of this paper.

CERTIFICATION UNDER 37 C.F.R. 1.8

I hereby certify that this document is being deposited on November 29, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Karla Biedenmeister